

EV085415213

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**TRANSMITTAL  
FORM**

(to be used for all correspondence after initial filing)

Total Number of Pages In This Submission

22

Application Number

09/536,037

Filing Date

March 27, 2000

First Named Inventor

Weimin (Michael) Li

Art Unit

2822

Examiner Name

Tonise M. Thomas

Attorney Docket Number

MI22-1398

**ENCLOSURES (Check all that apply)**

Fee Transmittal Form



Fee Attached



Amendment/Reply



After Final



Affidavits/declaration(s)



Extension of Time Request



Express Abandonment Request



Supplemental Information Disclosure Statement



Certified Copy of Priority Document(s)

Response to Missing Parts/  
Incomplete ApplicationResponse to Missing Parts  
under 37 CFR 1.52 or 1.53

Drawing(s)



Licensing-related Papers



Petition

Petition to Convert to a  
Provisional Application

Power of Attorney, Revocation



Change of Correspondence Address



Terminal Disclaimer



Request for Refund



CD, Number of CD(s) \_\_\_\_\_

After Allowance Communication  
to a Technology Center (TC)

Appeal Communication to Board



of Appeals and Interferences

Appeal Communication to TC  
(Appeal Notice, Brief, Reply Brief)

Proprietary Information



Status Letter

Other Enclosure(s) (please  
Identify below):

Remarks

Enclosures: PTO Return Receipt postcard; Supplemental Information Disclosure Statement with  
PTO Form 1449 and cited art.**SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT**Firm  
or  
IndividualD. Brent Kenady, Reg. No. 40,045  
Wells St. John P.S.

Signature



Date

7-16-03

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This collection of information is required by 37 CFR 1.5. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 12 minutes to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, Washington, DC 20231. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, Washington, DC 20231.

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EV085215213

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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 09/536,037  
Filing Date ..... March 27, 2000  
Inventor ..... Weimin (Michael) Li et al.  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... 2822  
Examiner ..... Toniae M. Thomas  
Attorney's Docket No. .... MI22-1398  
Title: Low k Interlevel Dielectric Layer Fabrication Methods

45/Supp  
IDS  
12-1003  
A.W.H.

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References - - See attached Form PTO-1449

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patents and other references listed on the attached Form PTO-1449. No admission is made regarding whether all the submitted references are prior art.

This Supplemental Information Disclosure Statement is being filed after the filing of the Request for Continued Examination (RCE) Application and before receipt of the first Office Action. Therefore, no fee is believed to be required. However, in the event that a fee is required for filing this Supplemental Information Disclosure Statement, please charge the fee specified under 37 C.F.R. §1.17(p) to Deposit Account No. 23-0925. Please credit Deposit Account No. 23-0925 with any overpayment of the above fee.

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**Match and Return**

Citation of these references is respectfully requested.

Respectfully submitted,

Date: 7-16-03



D. Brent Kenady  
Reg. No. 40,045

U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. M122-1398		SERIAL NO. 09/536,037		
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Weimin (Michael) Li et al.		
FILING DATE March 27, 2000				GROUP 2822		
U.S. PATENT DOCUMENTS						
*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	6,001,747	12/14/1999	ANNAPRAGADA	438	790
	AB					
	AC					
	AD					
	AE					
	AF					
	AG					
	AH					
	AI					
	AJ					
	AK					
	AL					
FOREIGN PATENT DOCUMENTS						
Document Number	Date	Country	Class	Subclass	Translation	
					Yes	No
AM						
AN						
AO						
AP						
AQ						
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)						
AR		"Silicon Processing for The VLSI Era"; Wolf, Stanley, Ph.D., Lattice Press 1986				
AS						
AT						
EXAMINER			DATE CONSIDERED			
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.						